

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 10/051,678  
Priority Filing Date ..... January 16, 2002  
Inventor ..... Li Li et al.  
Assignee ..... Micron Technology, Inc.  
Priority Group Art Unit ..... 2824  
Priority Examiner ..... Michael Lebentritt  
Attorney's Docket No. .... MI22-2441  
Title ..... Processing Method of Forming MRAM Circuitry

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
Commissioner for Patents  
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Alexandria, VA 22313-1450

**VIA EXPRESS MAIL**

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Please enter the following amendments prior to examining the above-identified application.

**AMENDMENTS**

**Amendments to the Title**

Please amend the title as following:

~~Methods of Forming Integrated Circuitry, Semiconductor Processing~~  
Methods, and Processing Method of Forming MRAM Circuitry